



**ELECTRONIC COPY**

LG778646304  
Report verification at igi.org



March 5, 2026  
IGI Report Number **LG778646304**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **8.46 X 6.08 X 3.96 MM**  
**GRADING RESULTS**  
Carat Weight **2.01 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

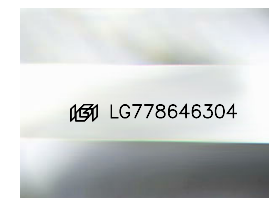
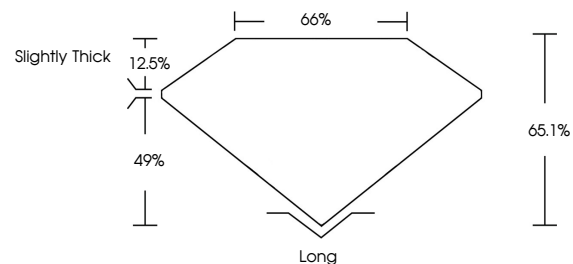
Carat Weight **2.01 CARATS**  
Color Grade **E**  
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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG778646304**

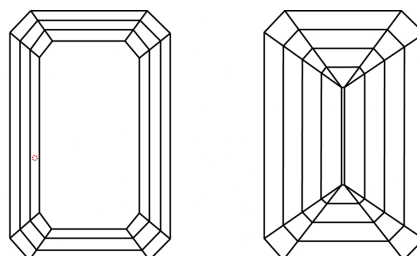
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

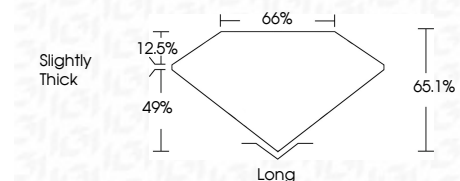
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Inscription(s) **IGI LG778646304**  
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**IGI**

March 5, 2026  
IGI Report No LG778646304  
**EMERALD CUT**  
8.46 X 6.08 X 3.96 MM  
2.01 CARATS  
E  
Color Grade  
VVS 2  
Depth 65.1%  
Table 66%  
Girdle  
Slightly Thick  
Culet  
Long  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG778646304  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa